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ROH-037

PCT SECTION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In the U.S. Nationalization)
Application of PCT/JP00/05596)
Kazutaka SHIBATA)
Application No. To Be Assigned) Attn: Application Branch
Filed: April 13, 2001)
For: SEMICONDUCTOR DEVICE AND)
METHOD FOR MANUFACTURING)
THE SAME)

PRELIMINARY AMENDMENT

Commissioner of Patents
Washington, DC 20231

Sir:

Prior to the initial examination, please amend the above-identified application as follows:

IN THE CLAIMS:

Please rewrite claims 5, 7, 9, 12, 15, 20, 21, 24 & 25 as set forth below in clean form. Additionally, in accordance with 37 CFR 1.121(c)(1)(ii), amended claims 5, 7, 9, 12, 15, 20, 21, 24 & 25 are set forth in a marked-up version in the pages attached to this Amendment.

A 5. (Amended) A method for manufacturing a semiconductor device as claimed in claim 3, further comprising
a step of forming projection electrodes on the surface of the semiconductor substrate